## LC/APC研磨盘独立式和固定式比較

	PH55-PL8A-48HP, 54HP	PH55-PL8A-48FX
LCAPC Duplex Connectors	Not supporting	Not su <del>pp</del> orting
In case of heavy and thick cable	△ Cable bending and pushing/pulling forces affect the independent load → Radius varies	O Not affected by cables.
Control of Radius	△ Adjustment can be done only by the hardness of the polishing pads. → Fine adjustment is not possible.	<ul> <li>Can be adjusted by both the hardness of the polishing pad and the polishing pressure. → Fine adjustment is possible.</li> </ul>
Effect of dirt on the polishing holder	<ul> <li>△ Dirt in the ferrule insertion hole affects the independent load. →</li> <li>Necessary to keep the insertion hole clean at all times.</li> </ul>	<ul> <li>Less susceptible to dirt than independent pressure holders.</li> </ul>

## 中国大陆代理商: